**2**001/016

FEB 0 6 2006

Docket No. 1232-5237

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

Akira KURIYAMA, et al.

Group Art Unit:

2812

Scrial No.:

10/735,062

Examiner:

E. PERT

Filed:

December 11, 2003

For:

SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE

SAME

Mail Stop <u>AMENDMENT</u> Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

#### CERTIFICATE OF FACSIMILE TRANSMISSION

Sir:

I hereby certify that the attached <u>Amendment and Request for Reconsideration</u>
(14 pages w/duplicated authorization page) is being transmitted on the date shown below to the <u>Examiner F. Pert of Group No. 2812</u> at the following facsimile number: (571) 273-8300.

Respectfully submitted,

MORGAN & FINNEGAN, L.L.P.

Dated: February 6, 2006

By:

Eric G. Wright

Registration No. <u>48,045</u> (202) 857-7887 Telephone (202) 857-7929 Facsimile

Correspondence Address:

MORGAN & FINNEGAN, L.L.P.

3 World Financial Center New York, NY 10281-2101

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# AMENDMENT &REQUEST FOR RECONSIDERATION UNDER 37 CFR § 1.111

Mail Stop: Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicants submit this Request for Reconsideration Under 37 C.F.R. §1.111 in response to the non-final Office Action dated November 4, 2005, and due on February 6, 2006 (February 4, 2006, being a Saturday). This amendment is timely filed.

For the Examiner's convenience:

- Amendments to the Title are reflected on page 2 of this paper;
- Amendments to the Specification are reflected on page 3 of this paper;
- Amendments to the Claims are reflected in the listing of claims beginning on page 10 of this paper;
- Remarks/Arguments begin on page 13 of this paper; and
- Authorization to charge additional fees to Deposit Account No. 13-4500 is on page 14 of this paper.

U.S. Serial No. 10/735,062

U.S. Docket No. <u>1232-5237</u>

#### Amendments to the Title

Please replace the current title of the invention with the following title:

-- A METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE-